

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	"20040141390"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 16:55
L2	21656	capacitor.clm.	US-PGPUB	OR	ON	2005/08/30 16:56
L3	2405	Atomic near layer near deposition	US-PGPUB	OR	ON	2005/08/30 16:56
L4	850	3.clm.	US-PGPUB	OR	ON	2005/08/30 16:56
L5	446	ALD.clm.	US-PGPUB	OR	ON	2005/08/30 16:57
L6	88	"O2" near plasma	US-PGPUB	OR	ON	2005/08/30 16:57
L7	5	6.clm.	US-PGPUB	OR	ON	2005/08/30 16:57
L8	0	2 and 7	US-PGPUB	OR	ON	2005/08/30 16:58
L9	128	2 and 5	US-PGPUB	OR	ON	2005/08/30 16:58
L10	676	Al2O3	US-PGPUB	OR	ON	2005/08/30 16:58
L11	21223	aluminum near oxide	US-PGPUB	OR	ON	2005/08/30 16:58
L12	21696	10 11	US-PGPUB	OR	ON	2005/08/30 16:59
L13	4722	12.clm.	US-PGPUB	OR	ON	2005/08/30 16:59
L14	329	2 and 13	US-PGPUB	OR	ON	2005/08/30 16:59
L15	35	14 and 5	US-PGPUB	OR	ON	2005/08/30 16:59
L16	97361	plasma	US-PGPUB	OR	ON	2005/08/30 16:59
L17	18598	16.clm.	US-PGPUB	OR	ON	2005/08/30 17:00
L18	18	17 and 15	US-PGPUB	OR	ON	2005/08/30 17:01
L19	2270	high adj K	US-PGPUB	OR	ON	2005/08/30 17:02
L20	382	19.clm.	US-PGPUB	OR	ON	2005/08/30 17:02
L21	0	18 and 20	US-PGPUB	OR	ON	2005/08/30 17:02
L22	0	6 and 18	US-PGPUB	OR	ON	2005/08/30 17:03